

<b>Notice of References Cited</b>	Application/Control No. 10/530,468	Applicant(s)/Patent Under Reexamination FUJIWARA, DAISUKE	
	Examiner Sing P. Chan	Art Unit 1734	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
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	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 2000159426 A	06-2000	Japan	FUJIWARA, DAISUKE	
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	English Machine Translation of JP 2000-159426
	V	English Abstract of JP 2000-159426
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	X	

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